

Supporting Materials

A Rapid and Substrate-Independent Layer-by-Layer Process for the Fabrication of Antireflection and Antifogging Coatings

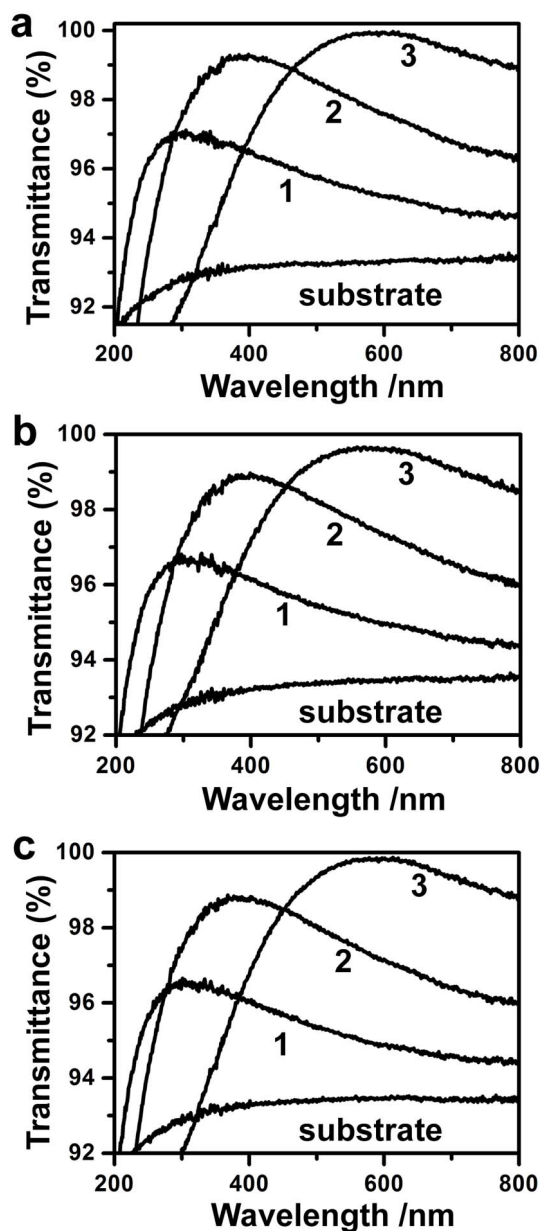


Fig. S1 UV-vis transmission spectra of LbL assembled MSiO₂/PDDA coatings on quartz substrates fabricated with different dipping times: (a) 5 min, (b) 10 min, (c) 20 min.

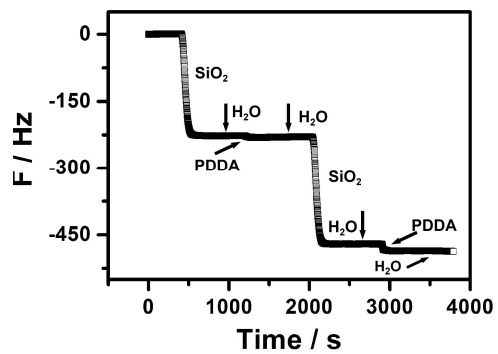


Fig. S2 *In situ* QCM measurements of alternate deposition of SiO₂ nanoparticles and PDDA.